	Application No.	Applicant(s)	
	10/667,973	FUJII ET AL.	
Notice of Allowability	Examiner	Art Unit	
	David Y. Chung	2871	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIG	(OR REMAINS) CLOSED in this a or other appropriate communication GHTS. This application is subject	pplication. If not included on will be mailed in due course.	
1. This communication is responsive to applicant's response to	to restriction filed 20 October 2005		
2. The allowed claim(s) is/are 1-13 and 20-24.			
3. \boxtimes The drawings filed on <u>23 September 2003</u> are accepted by	the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. 6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date (b) including indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. 			
 Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 30 September 2005 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. Interview Summar Paper No./Mail D 8), 7. Examiner's Amend	ate	

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EXAMINER'S AMENDMENT

This application is in condition for allowance except for the presence of claims 14-19 non-elected without traverse. Accordingly, claims 14-19 been cancelled.

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Allowable Subject Matter

The following is an examiner's statement of reasons for allowance: none of the prior art of record taught or suggested that the transparent layer on the second substrate is not provided in at least part of the non-display portion where the driving devices and wiring are provided so that a gap in the transparent layer is provided in an area corresponding to where the driving devices and wiring are provided.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to David Chung whose telephone number is (703) 306-0155. The examiner can normally be reached on Monday-Friday from 8:30 am to 5:00 pm.

KENNETH PARKER
PRIMARY EXAMINER

David Chung GAU 2871 11/28/05